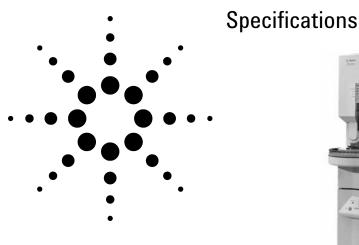
# Agilent 6850 Series II Network GC System



# Description

The single-channel Agilent 6850 Series II Network GC system has similar state-of-the-art performance as the Agilent 6890N GC, but is only half as wide. The six-button, twoline local interface provides run control and status information. The GC is network-ready with a built-in LAN communications interface. The GC is also automatic liquid sampler (ALS)-ready with built-in controller for the G2880 autosampler or the Agilent 7683 autoinjector. A removable handheld control module is one of several options available for setpoint entry and diagnostics.

### **Environmental Conditions**

- Ambient operating temperature: 15 °C to 35 °C
- Ambient operating humidity: 5% to 95%
- Storage extremes: -40 °C to 70 °C
- Heat dissipation: 3,000 Btu/h, 0.88 kW typical (at 100–120 V)

### **Power Requirement**

#### **Standard Oven**

• Approximately 1,440 VA (max) at 100–120 V, 2,000 VA at 230 V

- 100 V (+10%, -10%), 15 amps, 47-63 Hz
- 120 V (+10%, -10%), 12 amps, 47-63 Hz
- 230 V (+10%, -10%), 9 amps, 47-63 Hz

### Fast Oven

- 120 V (+10%, -10%), 20 amps, 47-63 Hz
- 200/208 V (+10%, -10%), 12 amps, 47–63 Hz
- 230 V (+10%, -10%), 11 amps, 47-63 Hz

# Certifications

- Conforms to the following safety standards:
  - Canadian Standards Association (CSA): C22.2 No. 1010
  - CSA/Nationally Recognized Test Laboratory (NRTL): UL 3101
  - International Electrotechnical Commission (IEC): 1010-1
  - EuroNorm (EN): 61010-1
- Conforms to the following regulations on Electromagnetic Compatibility (EMC) and Radio Frequency Interference (RFI):

- CISPR 11/EN 55011: Group 1 Class B
- EN 50082-2: 1996 EMC Generic Immunity Standard: Industrial Environment
- IEC68-2-27 Mechanical Shock Test Standard
- Designed and manufactured under a quality system registered to ISO 9001
- Declaration of Conformity available

# **Column Oven**

- Dimensions: 202 × 200 × 105 mm (HWD)
- Oven power is turned off automatically when the lid is opened
- Column basket diameter: 130 mm
- Standard: 5 °C above ambient to 350 °C. With CO<sub>2</sub> cryo: -20 °C to 350 °C.
- Temperature setpoint resolution: 1 °C
- Column bleed compensation
- Maximum run time: 999.99 min
- Temperature programming: six ramps with seven plateaus



- Ambient rejection: <0.01 °C per 1 °C ambient change
- Automatic  ${\rm H_2}$  carrier safety turn-off when inlet gas pressure drops
- Typical cool-down rate: 350 °C to 50 °C: 5.2 min
- Cryogenic gas consumption is typically half that of dual-channel ovens

#### Table 1. Typical Oven Ramp Rates (at nominal line voltage)

(at noniniai nito voitago)		
Temperature range in °C	Standard oven rates (°C/min)	Fast oven rates (°C/min)
50 to 75	120	240
75 to 115	95	190
115 to 175	65	130
175 to 300	45	90
300 to 350	35	70

# Inlets

### Inlets Available:

- Split/Splitless capillary inlet (S/SL)
- Purged packed injection port (PPIP)
- Temperature-programmable vaporizer (PTV)
- Temperature-programmable cool-on-column (PCOC)
- Electronic pneumatics control (EPC)
- When capillary column dimensions are entered, the actual flow and pressure are shown as calibrated digital readouts
- Carrier gas selection provided for: He,  $H_2$ ,  $N_2$  and Ar-CH<sub>4</sub>
- Pressure setting range: 0 to 100 psi
- Constant pressure, constant flow modes
- Three ramps for pressure or flow
- Optional Merlin Microseal septum guarantees at least 2,000 injections
- Septum purge set automatically

#### Split/Splitless Capillary Inlet

- Maximum temperature: 375 °C
- Pressure range: 0–100 psi (0–150 psi optional)
- Accepts columns from 50-µm id to 530-µm id
- Pressure pulse mode
- Gas saver mode
- Total flow ranges through the inlet: He, 20 to 1,000;  $H_2$ , 26 to 1,000;  $N_2$ , 20 to 200 mL/min
- Split ratio may be adjusted electronically without affecting column flow or head pressure

#### **Purged-Packed Injection Port**

- Maximum temperature: 375 °C
- Accepts 530-µm capillary columns or 1/8-inch metal-packed columns up to 20 feet in length
- Total flow setting range: 0-100 mL/min

### PTV

- Maximum temperature: 375 °C
- Three temperature program ramps
- Temperature ramp rates 0.1 to 720 °C/min
- Pressure setting range: 0–100 psi
- Total flow setting range: 0 to 200 mL/min N<sub>2</sub> 0 to 1,000 mL/Min H<sub>2</sub> or He
- Available with LCO<sub>2</sub> cyrogenic cooling only
- Lower temperature limit without CO<sub>2</sub>: ambient plus 10 °C
- Lower temperature with LCO<sub>2</sub> cyrogenic cooling: -30 °C (10 °C less than oven)
- Available with Gerstel septumless head or Merlin MicroSeal septum head

### PCOC

- Maximum temperature: 375  $^{\circ}\mathrm{C}$
- Three temperature program ramps or oven track mode

- Maximum temperature ramp rate: 350 °C/min
- Pressure setting range: 0–100 psi
- Total flow setting range: 0 to 100 mL/min
- Available with LCO<sub>2</sub> cyrogenic cooling only
- Lower temperature limit without  $LCO_2$  cyrogenic cooling: Oven temperature plus 3 °C with oven track on, -20 °C with oven track off
- Lower temperature with LCO<sub>2</sub> cyrogenic cooling:
   -17 °C with oven track on
   -20 °C with oven track off

### Detectors

Detectors include EPC.

### Flame Ionization Detector (FID)

- Maximum temperature: 375 °C
- Automatic ignition
- Flame-out detection and reignition
- Minimum detectable: <5 pg carbon/s as propane using  $N_2$  carrier and a 0.29-mm id jet
- Linear dynamic range: 10<sup>7</sup>(±10%)
- Full range auto scaling
- Data acquisition rate: up to 200 Hz
- Flows: air, 0 to 800; hydrogen, 0 to 100; make-up (He or  $N_2$ ), 0 to 100 mL/min

#### **Thermal Conductivity Detector (TCD)**

- Maximum temperature: 375 °C
- Minimum detectable: <400 pg propane/mL helium carrier (MDL can be affected by laboratory environment.)
- Linear dynamic range:  $10^5 (\pm 5\%)$
- Flows: reference gas, 0 to 100; make-up (He, H<sub>2</sub>, N<sub>2</sub>), 1 to 12 mL/min

- FPD
- Available in single wavelength only
- 250 °C maximum operating temperature
- MDL: <20 pg S/s, <0.9 pg P/s with dodecanethiol/tributylphosphate mixture
- Selectivity: 10<sup>5</sup> gS/gC, 10<sup>6</sup> gP/gC
- Dynamic range: >10<sup>3</sup> S, 10<sup>4</sup> P with dodecanethiol/tributylphosphate mixture

### Micro-ECD

- Equipped with hidden anode and high velocity flows for contamination resistance
- 400 °C maximum operating temperature
- Makeup gas types: argon/5% methane or nitrogen
- Radioactive source: <15 mCi<sup>63</sup> Ni
- MDL: <0.008 pg/s lindane
- Dynamic range: >5 × 10<sup>5</sup> with lindane
- Data acquisition rate: up to 50 Hz



# Local User Interface

- Six-button interface with two-line display:
  - Status is on the top line; lists and messages are on the bottom line.
  - ▼▲ buttons scroll through a list.
  - LOAD button loads a method.
  - PREP RUN button prepares the unit for manual injection.
- START/STOP buttons control the sequence or method.
- Keyboard can be locked.

### General

- Clock-time programming (24 h)
- Up to five methods stored, builtin SERVICE method
- One sequence
- Run deviation log
- Contact closure (48 VAC/VDC 250 mA) with BCD input to control external multiposition valve (up to 16 positions).
- Internal valve control; 24 VDC, 200 mA
- Built-in power/control for the Agilent 7683 autoinjector

### **Data Communications**

- RS-232-C: maximum Baud rate is 57,600
- Analog outputs (1 mV, 1 V, 10 V)
- Remote start/stop
- LAN interface

### EPC

### Standard

- Pressure setpoint increments: 0.01 psi
- Temperature and pressure sensors compensate for ambient variation and altitude
- All EPC setpoints are included in the method

### Auxiliary (Aux) EPC

- Maximum number of modules: one
- Maximum number of channels: three
- Pressure increments: 0.01 psi
- Maximum pressure: 100 psig
- Maximum pressure ramp rate (when configured as Inlet): 150 psi/min

# Valving (optional)

One 6-port gas sampling valve or one 4-port liquid sampling valve can be mounted in a heated compartment. The valve can be connected to the column either directly or via the inlet. Valves may be run-time programmed. Actuating a sampling valve will START a run.

Both the traditional actuator/rotary valves as well as piston/diaphragm valves are available. The rotary valves are suitable for most applications. The air-actuated diaphragm valves have a much longer life and are easier to maintain; however, they are not suitable for ammonia, primary and secondary amines, hydrazines, strong oxidizers, and alkaline solutions (pH >10).

The recommended operating temperature and pressure ranges for the miniature VICI® diaphragm design are: 50 to 150 °C and 20–300 psi. The valves are actuated pneumatically and require 40 to 50 psi air pressure.

The recommended operating temperature range for the rotary 6-port gas sampling valve is 50 to 200  $^{\circ}$ C and the maximum sample pressure is 400 psi.

The operating temperature range for the rotary 4-port liquid sampling valves is 70 °C to 175 °C. At 5000 psi, the maximum temperature is 75 °C while at 1000 psi the maximum temperature is 175 °C.

The gas sampling valve, rotary or diaphragm, is supplied with a 0.25-cc loop. Other loops (0.5, 1, and 2 cc) are available separately.

Liquid sample valves have a built-in sample loop (0.5 or  $1.0-\mu$ L size).



### Agilent 6850 GC Handheld Control Module (optional)

- Graphical user interface
- Attaches with a coiled cable
- Permits method creation, editing, and transfer among Agilent 6850 GCs, using a flash memory card
- Provides complete programming and control of the Agilent 6850 GC, Agilent G288A autosampler, all 6850 inlets and detectors, Agilent 7683 autoinjector, and valves\*
- Displays real-time signal plot, such as detector signal
- Context-sensitive Help
- Alphanumeric characters can be entered for method names
- Provides access to log book, run log, and calibration
- Provides diagnostic tools including Early Maintenance Feedback (EMF) and leak testing for PTV

\*As with the 6890N GC, variable speed injection can only be controlled by PC interfaces.

### **Maintenance and Support**

- Service method sets temperatures and flows for routine maintenance (such as septum or liner changing)
- Operating and service information on CD-ROM. Includes multimedia maintenance procedures
- Diagnostics built into the (optional) handheld controller for use by the operator:
  - Inlet (leak) test
  - Inlet vent trap (restriction) test
  - FID jet (restriction) test
- Additional diagnostic tests built in for hardware fault detection

### **Dimensions and Weight**

- Height: 490 mm to FID cover top, and 505 mm to top of valve box
- Width: 283 mm, or 333 mm if the cryogenic option is installed
- Depth: 568 mm
- Weight: 29 kg (maximum)

Agilent shall not be liable for errors contained herein or for incidental or consequential damages in connection with the furnishing, performance, or use of this material.

Information, descriptions, and specifications in this publication are subject to change without notice.

VICI® is a registered trademark of Valco Instruments Co. Inc. and VICI AG.

© Agilent Technologies, Inc. 2004

Printed in the USA April 13, 2004 5989-0958EN

